

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Padiyar, et al.

Application No.: 10/816,019

Filed: March 31, 2004

For: LIGHT SOURCE FOR  
PHOTOLITHOGRAPHY

Examiner: Nguyen, Hung

Art Unit: 2851

Confirmation No.: 2653

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY UNDER 37 CFR §1.116 EXPEDITED PROCEDURE**

Dear Examiner:

This is in response to the Final Office Action mailed April 20, 2009. Applicants respectfully request the Examiner to enter this response and consider the following remarks.

**The Listing of Claims** begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

I hereby certify that this correspondence is being deposited via  
EFS Web on the date below:

June 22, 2009

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/Gigi Hoover/

Gigi Hoover